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November 28, 2003

In Affiliation with
Weiss, Moy & Harris, PC
having offices in Arizona and Nevada,
and in Washington, DC with
Rabin & Berdo, PC



Mail Stop Patent Application

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Attorney Reference: OKI 388

Re: New Patent Application of: Yoshimi EGAWA
Title: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD
THEREOF

Sir:

Please find attached hereto an application for patent which includes:

- ☒ Specification, Claims and Abstract (27 Pages)
- ☒ 9 Sheets of Formal Drawings (Fig. 1A through Fig. 8I)
- ☒ Inventor's Declaration and Power of Attorney (3 Pages)
- ☒ Assignment document with cover page (2 Pages)
- ☒ Claim for priority and the priority document
- ☒ Information Disclosure Statement, Form PTO-1449, and copies of two references
- ☒ Fee (see formula below)

Basic Fee \$770/385 \$ 770.00

Additional Fees:

Total number of claims: 19
in excess of 20: 0 times \$18/9 \$ 0.00

Number of independent claims: 3
in excess of 3: 0 times \$86/43 \$ 0.00

Multiple Dependent Claims \$290/145 \$ 0.00

Recording Fee \$40. \$ 40.00

TOTAL FEES FOR THE ABOVE APPLICATION \$ 810.00

In the event there is attached hereto no check or form PTO-2038 (credit card payment form), or a check or form for an insufficient amount, please charge the fee or insufficiency to our Account No. 18-0002 and notify us accordingly.

The rights of priority are claimed under 35 USC §119 of Japanese Application No. 2002-372734, filed December 24, 2002.

Respectfully submitted,



Steven M. Rabin (Reg. No. 29,102)
(Customer No. 23995)

November 28, 2003
Date
SMR:tl

FEE ENCLOSED: \$810.
Please charge any further
fee to our Deposit Account
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